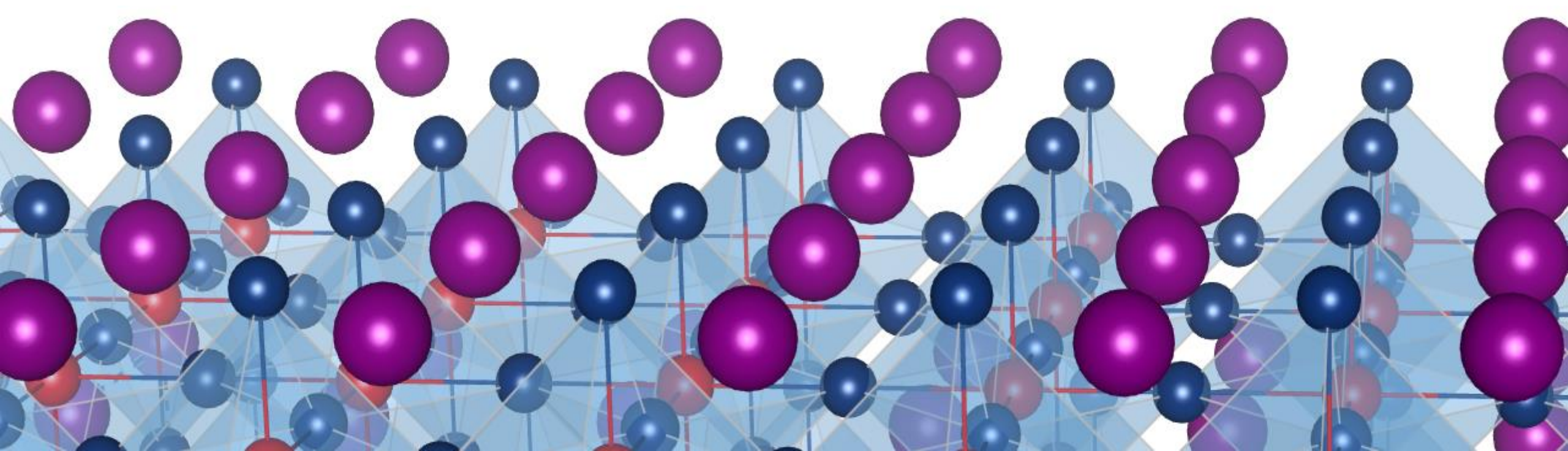




A MULTILAYER MODEL TO UNDERSTAND THE CAPACITANCE RESPONSE OF PEROVSKITE SOLAR CELLS

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overview

1. Discussion of capacitance methods commonly used to characterise perovskite solar cells –
 - Capacitance-voltage (CV) profiling
 - Mott-Schottky plots and doping profiles
 - Thermal admittance spectroscopy (TAS) measurements
 - Time domain transients

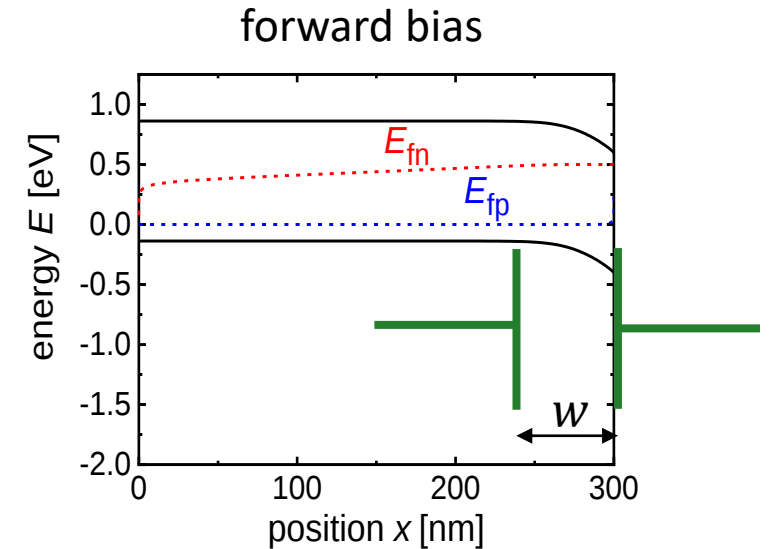
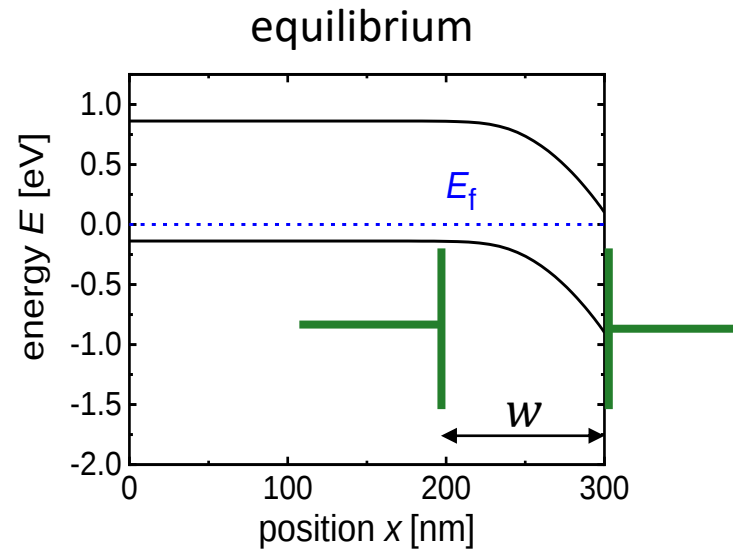
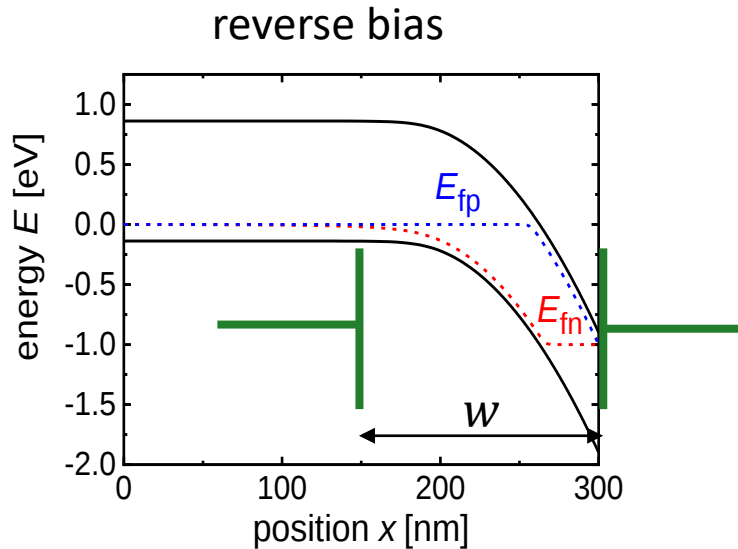
2. Interpretation of the high or intermediate frequency (non-ionic) capacitance response of perovskite solar cells in these methods using a multilayer capacitance model.

depletion region capacitance

band bending determined by
Poisson equation

$$\frac{d^2V}{dx^2} = -\frac{q}{\epsilon_r\epsilon_0} [N_D^+(x) - N_A^+(x)]$$

dopant/trap densities



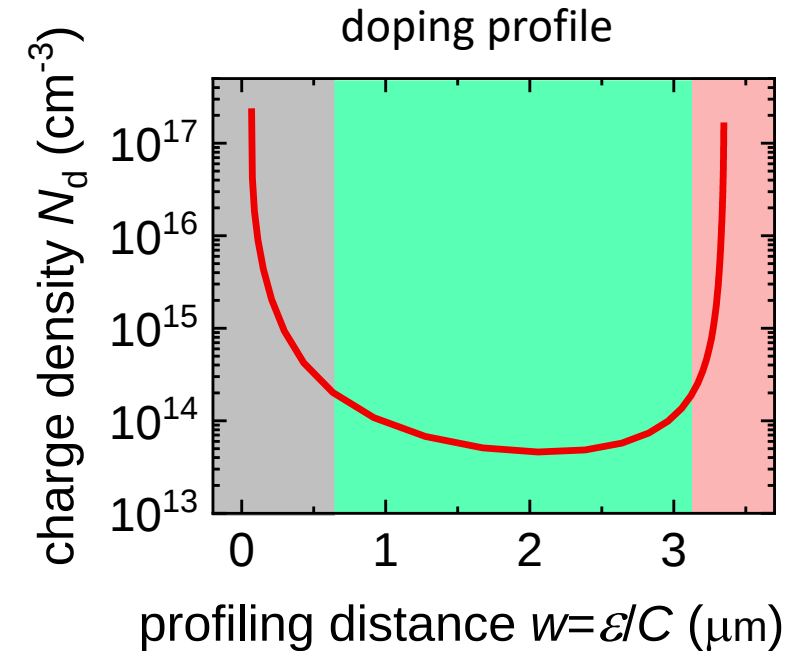
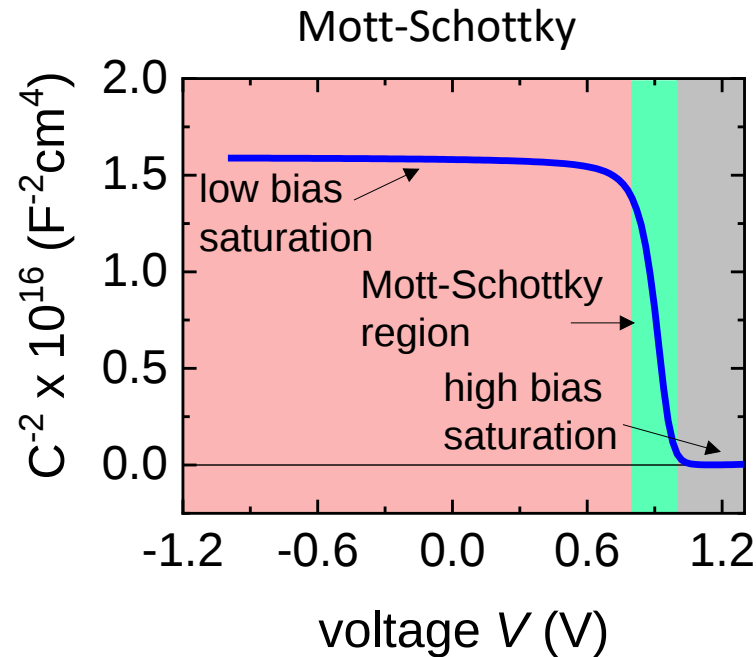
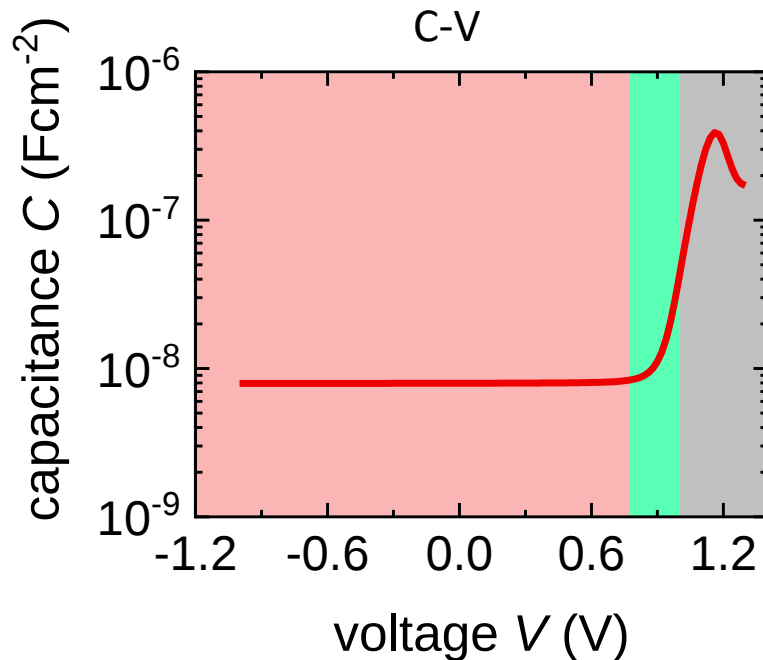
$$C(V) = \frac{\epsilon_r\epsilon_0}{w(V)}$$

Mott-Schottky plot and doping profile

$$C(V) = \sqrt{\frac{q\epsilon_r\epsilon_0 N_D}{2(V_{bi} - V)}}$$

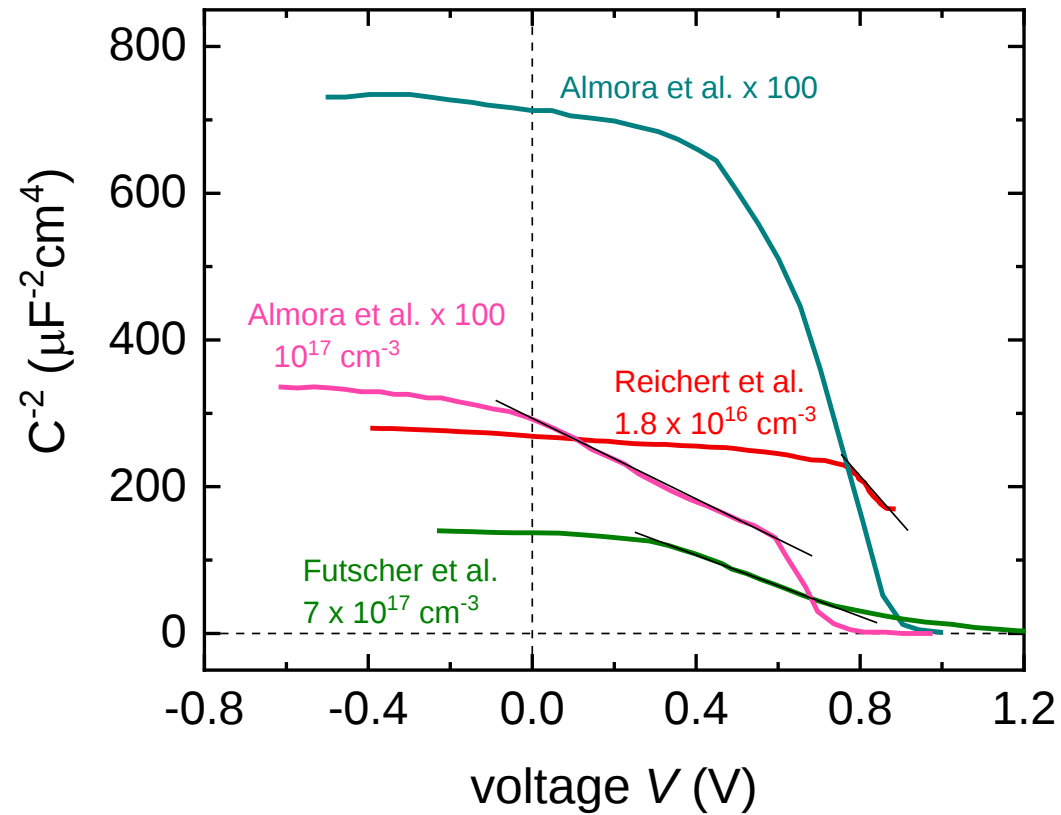
$$C^{-2}(V) = \frac{2}{q\epsilon_r\epsilon_0 N_D} (V_{bi} - V)$$

$$N_D(V) = \frac{-2(dC^{-2}/dV)^{-1}}{q\epsilon_r\epsilon_0}$$



provides important parameters – doping/trap density, built-in voltage, Debye length

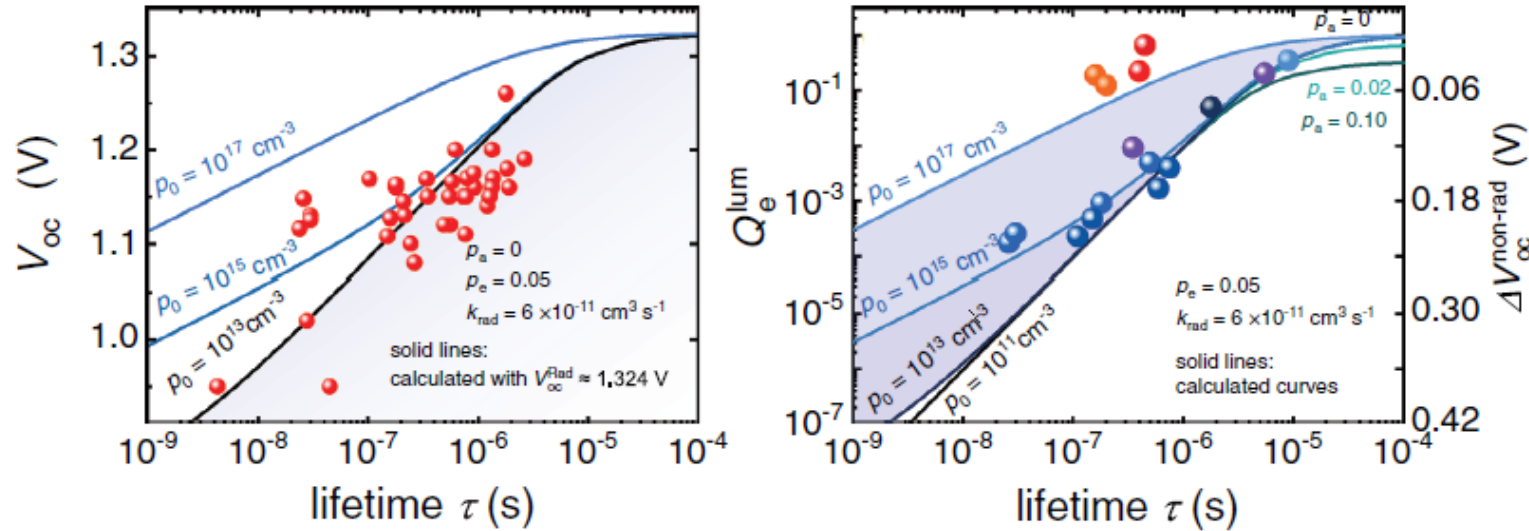
perovskite Mott-Schottky plots



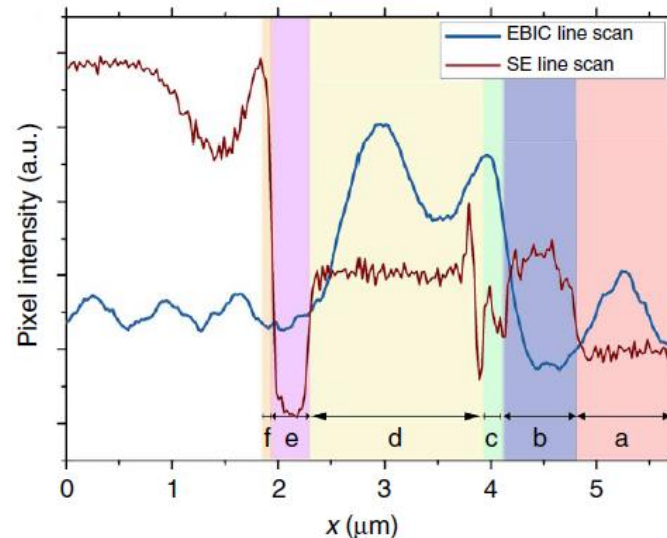
reported doping densities
between 10^{16} - $10^{18} cm^{-3}$

doped or intrinsic?

luminescence data, Kirchartz et al., 2020



some evidence of intrinsic perovskites

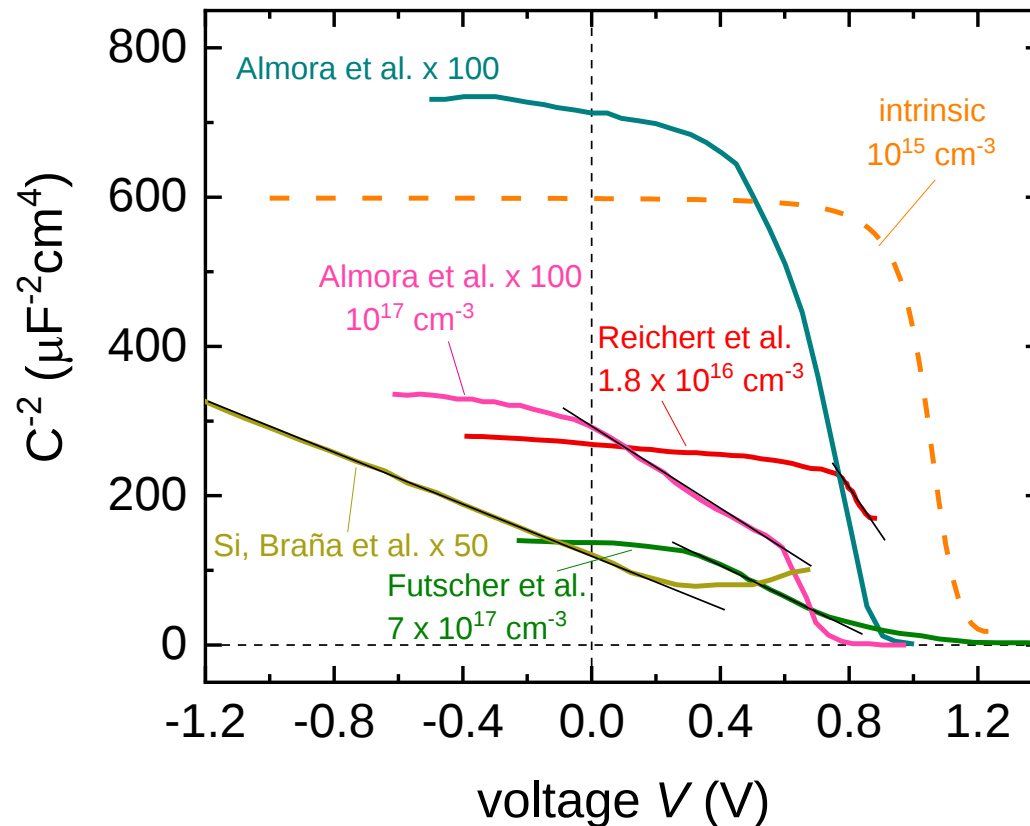


EBIC measurements
Edri et al., 2014

Edri, E., Kirmayer, S., Mukhopadhyay, S., Gartsman, K., Hodes, G. and Cahen, D., 2014. *Nature communications*, 5(1), pp.1-8.

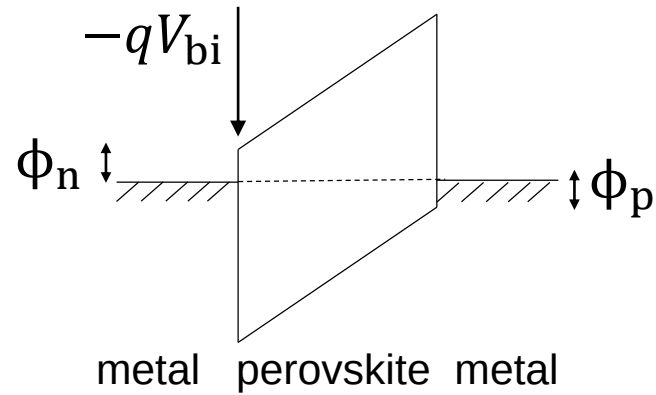
Kirchartz, T., Márquez, J.A., Stolterfoht, M. and Unold, T., 2020. *Advanced energy materials*, 10(26), p.1904134.

perovskite Mott-Schottky plots

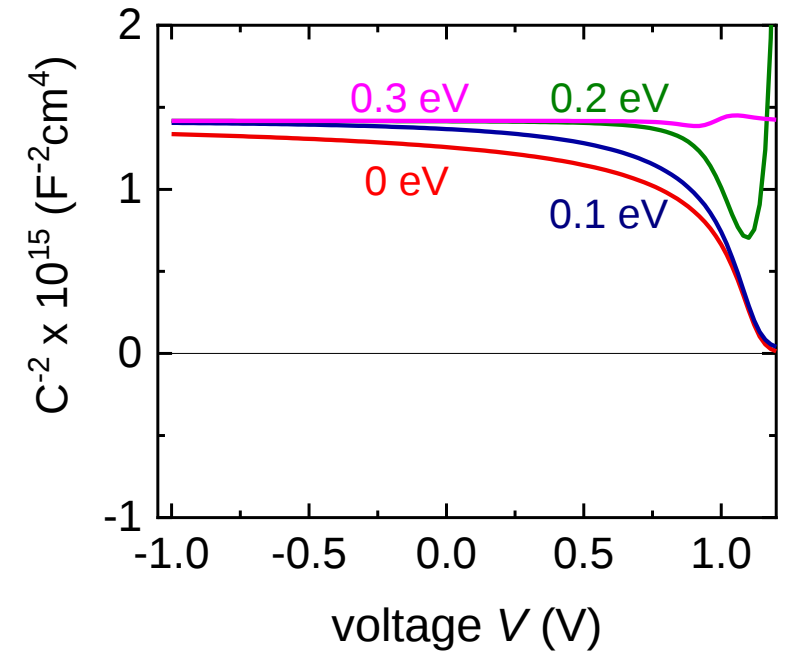
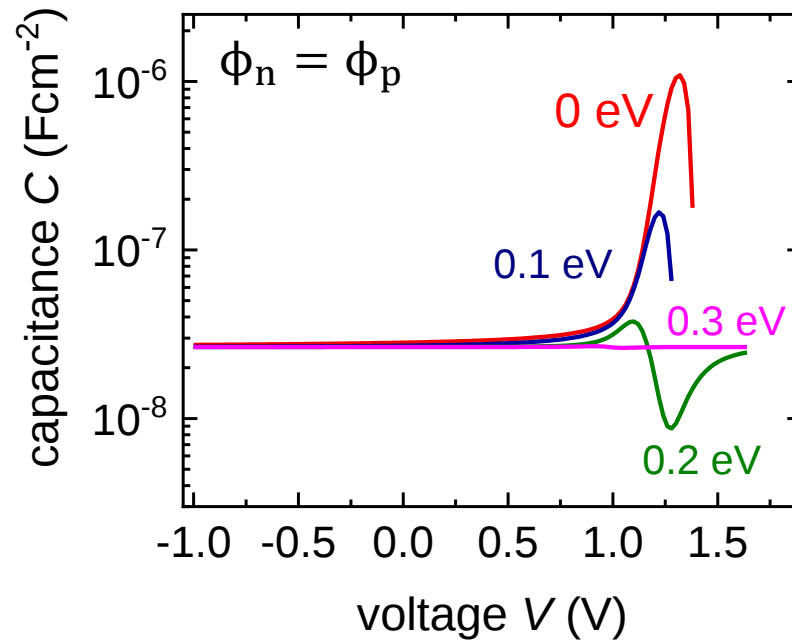
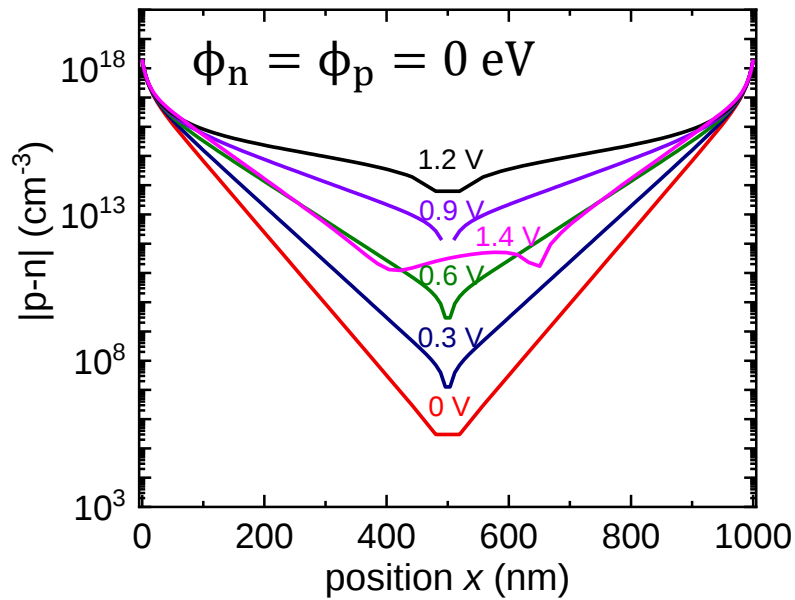


why does an intrinsic semiconductor make an apparent Mott-Schottky behaviour at forward bias?

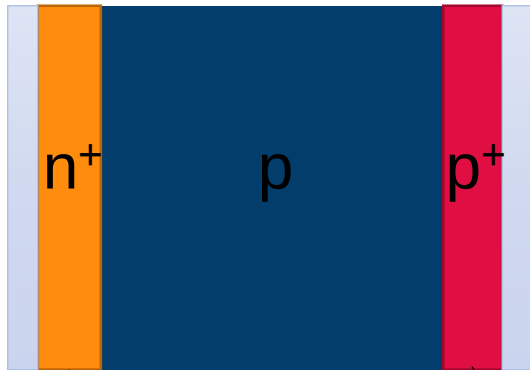
chemical capacitance



$$C_{\mu} = C_0 \exp \frac{qV}{mk_B T}$$

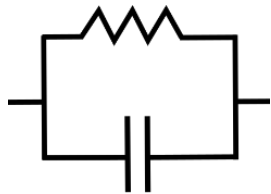


Si solar cell



$$N_d = 10^{20} \text{ cm}^{-3}$$

$$N_a = 10^{19} \text{ cm}^{-3}$$

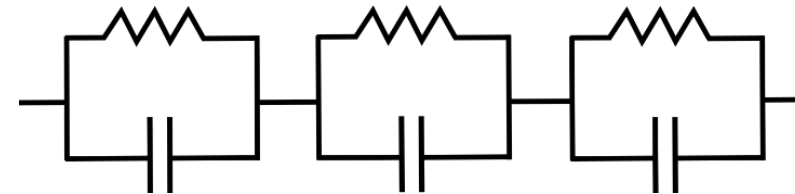


perovskite solar cell



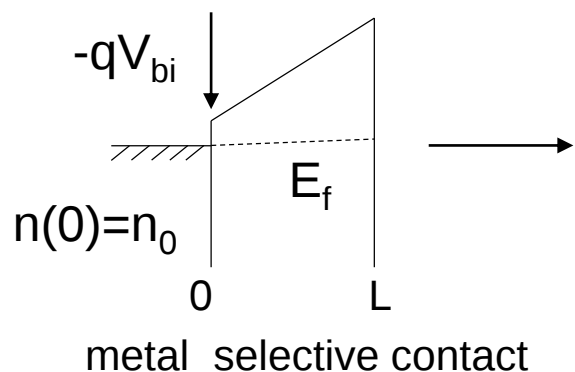
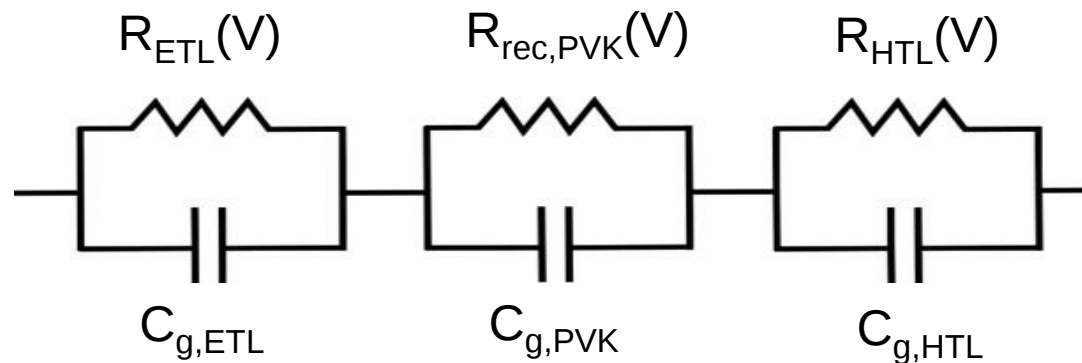
$$\text{PCBM, C}_{60}, \text{TiO}_2 \\ 10^{-5} - 10^{-2} \text{ cm}^2 \text{V}^{-1} \text{s}^{-1}$$

$$\text{PTAA, P3HT, Spiro-OMeTAD} \\ 10^{-5} - 10^{-2} \text{ cm}^2 \text{V}^{-1} \text{s}^{-1}$$



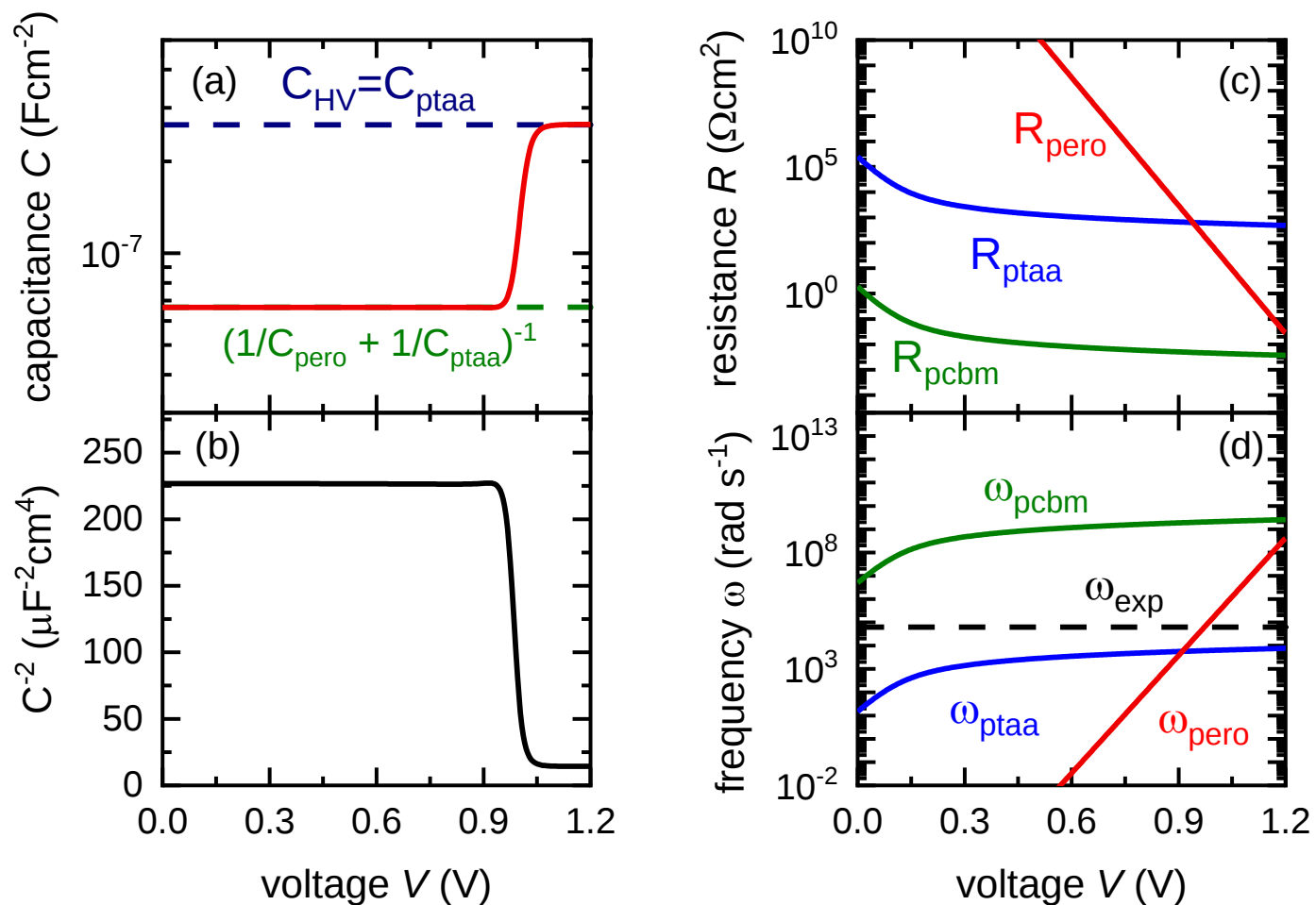
capacitances of the selective contacts cannot be neglected, due to their resistances

multilayer capacitance model



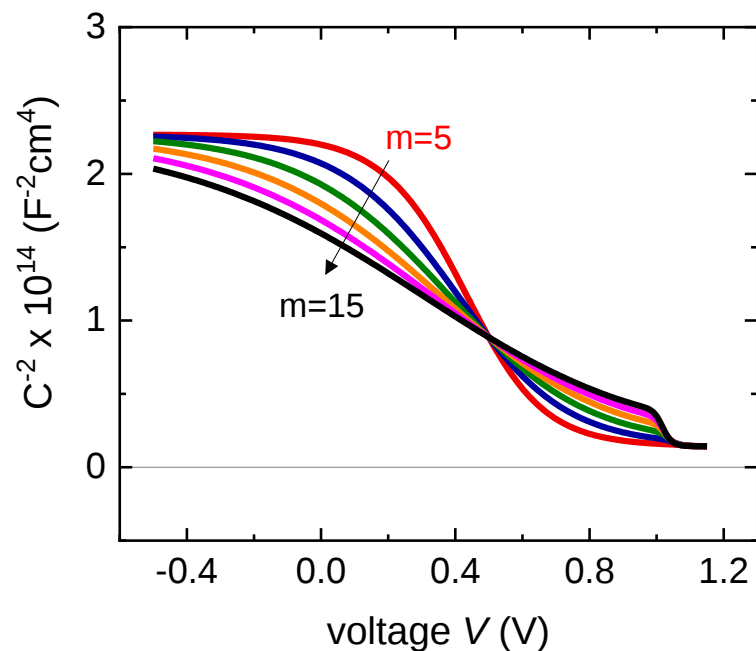
$$R_{\text{ETL/HTL}}(V) = \frac{1}{L} \int_0^L \frac{L}{\sigma(x)} dx = \frac{L}{q\mu n_0 \left(\frac{q(V_{\text{bi}} - V)}{mk_B T} \right)} \left[\exp \left(\frac{q(V_{\text{bi}} - V)}{mk_B T} \right) - 1 \right]$$

$$C_{\text{net}}(V) = \frac{1}{i\omega Z_{\text{net}}} = \left(\frac{i\omega R_{\text{ETL}}}{1 + \frac{i\omega}{\omega_{\text{ETL}}}} + \overset{\propto \exp\left(\frac{q(V_{\text{bi}} - V)}{n_{\text{ID}} k_B T}\right)}{\frac{i\omega R_{\text{rec,PVK}}}{1 + \frac{i\omega}{\omega_{\text{PVK}}}}} + \frac{i\omega R_{\text{HTL}}}{1 + \frac{i\omega}{\omega_{\text{HTL}}}} \right)^{-1} \rightarrow \omega_{\text{char}} = \frac{1}{RC}$$

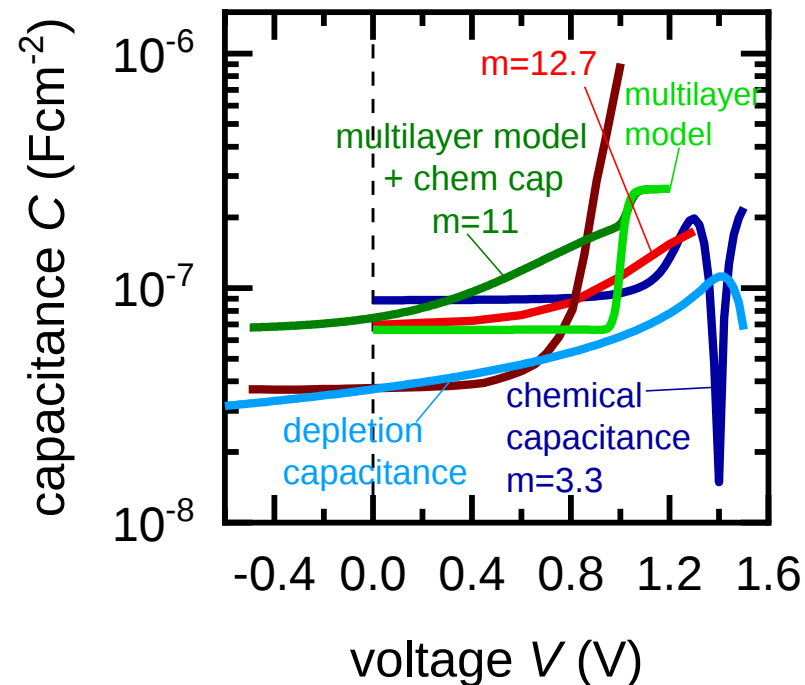


magnitude of characteristic frequency in comparison to experiment frequency determines which capacitance will be expressed at a given voltage

multilayer model +
chemical capacitance



capacitance-voltage



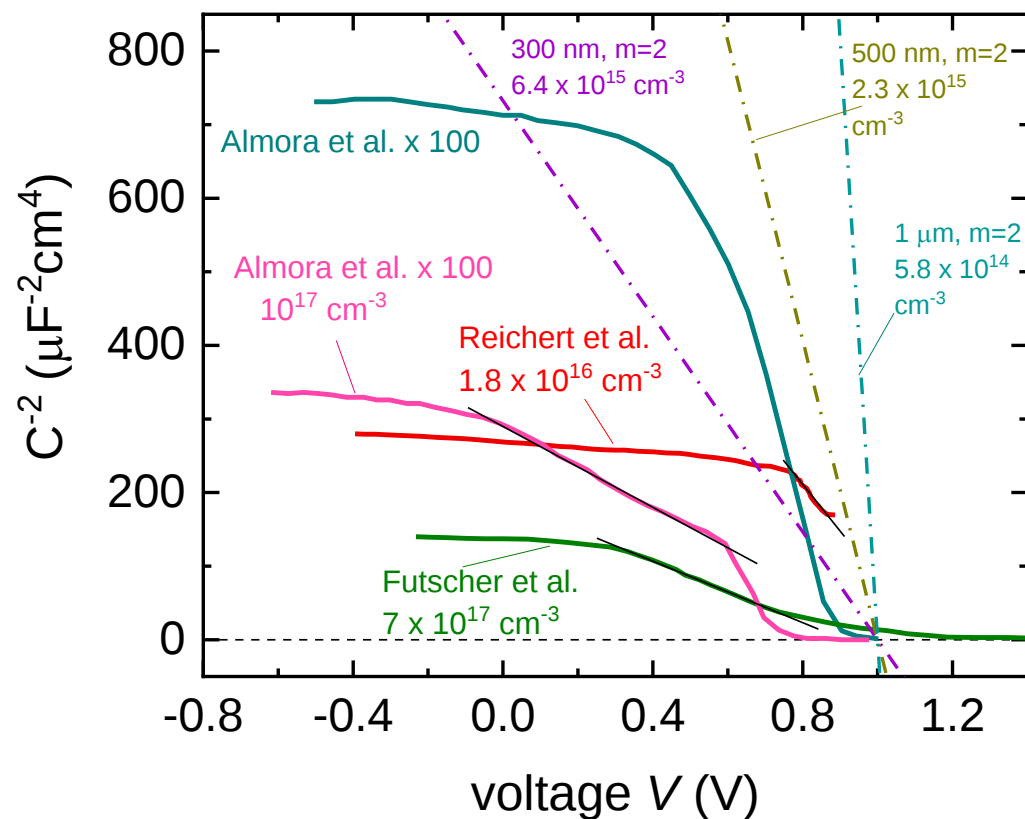
forward bias yields general
capacitance evolution of the form

$$C(V) = C_g + C_0 \exp \frac{qV}{mk_B T}$$

depletion capacitance can be
resolved only at reverse bias

Mott-Schottky formalism of general capacitance

$$C(V) = C_g + C_0 \exp \frac{qV}{mk_B T} \longrightarrow N_{d,\min} = \frac{27mk_B T \epsilon_r \epsilon_0}{4q^2 d^2}$$



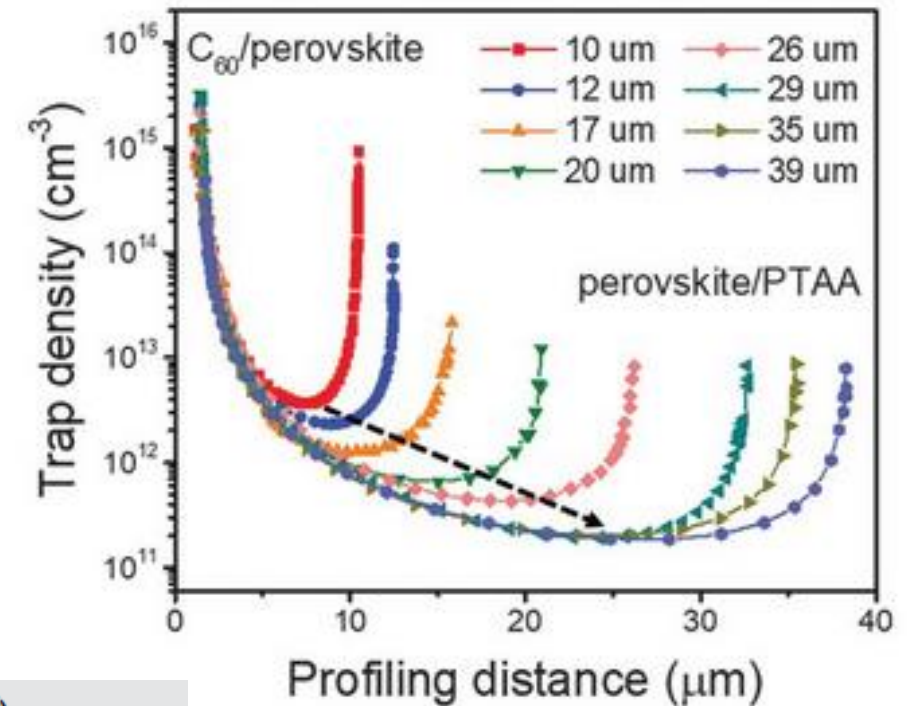
- charge injection + multilayer capacitance transitions cause a minimum charge density to be observed
- in this limit, thin films always show higher apparent trap/doping densities compared to bulk single crystals

drive-level capacitance profiling (DLCP)

$$Q(\bar{V} + \tilde{V}) = \frac{d\bar{Q}}{d\bar{V}} \tilde{V} + \left(\frac{d^2\bar{Q}}{2d\bar{V}^2} \right) \tilde{V}^2 + \dots$$

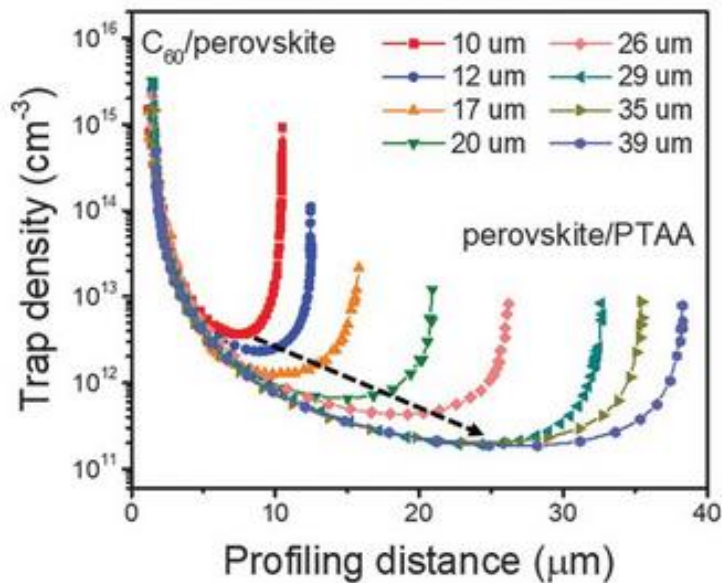
$$C = \frac{d\bar{Q}}{d\tilde{V}} = C_0 + C_1 \tilde{V} + \dots$$

↓
CV

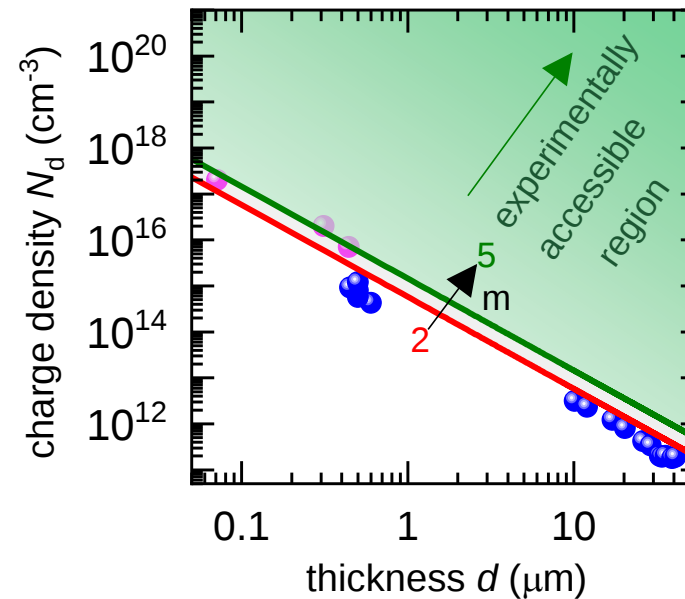
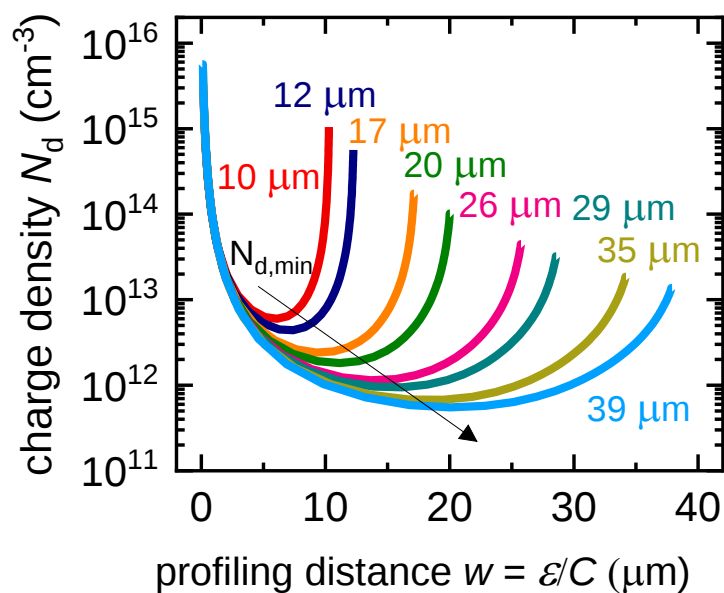


Perovskite material	Minimal bulk trap density ($N_{T \min}$) (cm^{-3})	Interface trap density (cm^{-3})	
MAPbBr ₃ single crystal (bulk)	6.5×10^{10}	1.8×10^{12} (C ₆₀)	1.8×10^{12} (Au)
MAPbI ₃ single crystal (bulk)	1.8×10^{11}	1.2×10^{12} (C ₆₀)	1.2×10^{12} (Au)
MAPbI ₃ single crystal (thin)	1.9×10^{11} to 3.2×10^{12}	2.0×10^{13} to 1.1×10^{16} (C ₆₀)	1.5×10^{13} to 1.0×10^{15} (PTAA)
Cs _{0.05} FA _{0.70} MA _{0.25} PbI ₃ film	4.3×10^{14}	8.6×10^{15} (C ₆₀)	1.2×10^{17} (PTAA)
Rb _{0.05} Cs _{0.05} FA _{0.75} MA _{0.15} Pb(I _{0.95} Br _{0.05}) ₃ film	5.7×10^{14}	2.0×10^{16} (C ₆₀)	1.1×10^{17} (PTAA)
FA _{0.92} MA _{0.08} PbI ₃ film	7.9×10^{14}	1.9×10^{16} (C ₆₀)	9.0×10^{15} (PTAA)
MAPbI ₃ film	9.2×10^{14}	2.2×10^{16} (C ₆₀)	1.2×10^{17} (PTAA)
Cs _{0.05} FA _{0.8} MA _{0.15} Pb _{0.5} Sn _{0.5} (I _{0.85} Br _{0.15}) ₃ film	1.2×10^{15}	1.5×10^{16} (C ₆₀)	1.1×10^{17} (PTAA)

DLCP



SCAPS, dopant and trap-free PSC



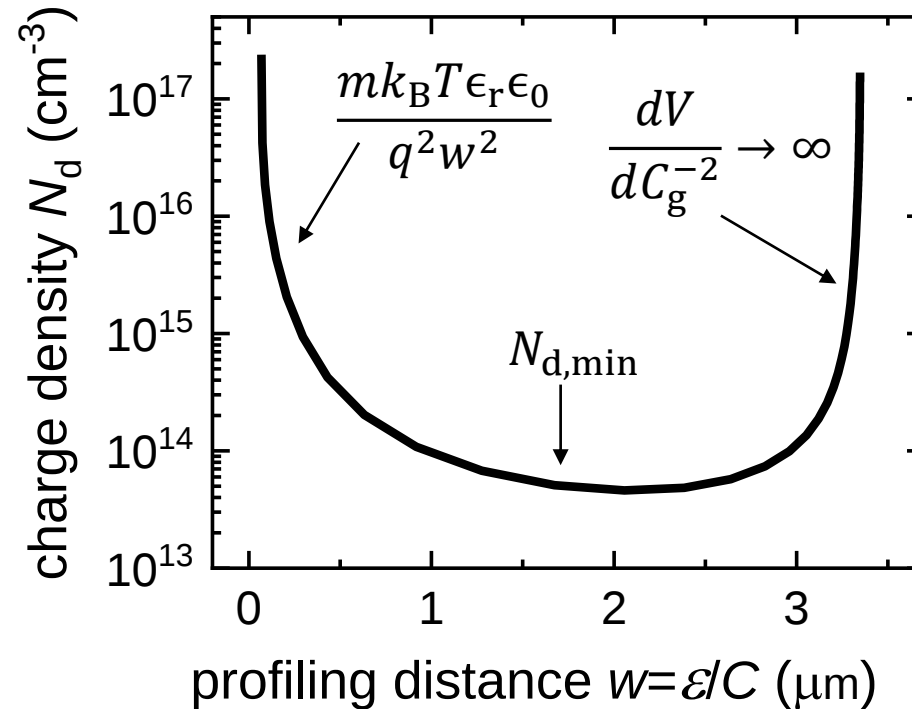
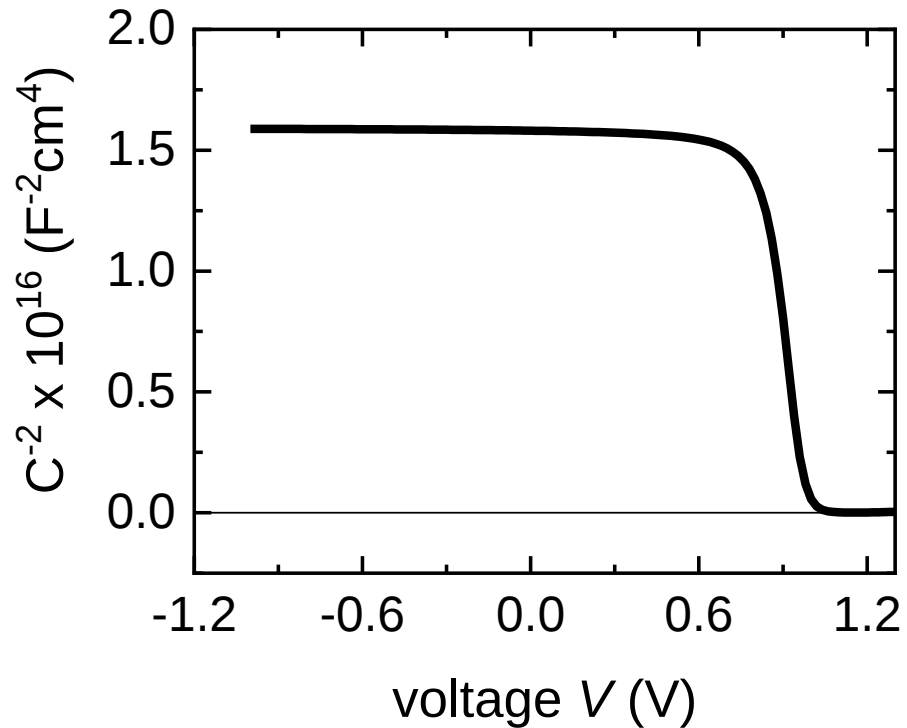
apparent minimum trap
densities below resolution limit

$$N_{d,\min} = \frac{27mk_B T \epsilon_r \epsilon_0}{4q^2 d^2}$$

doping profile – multilayer model

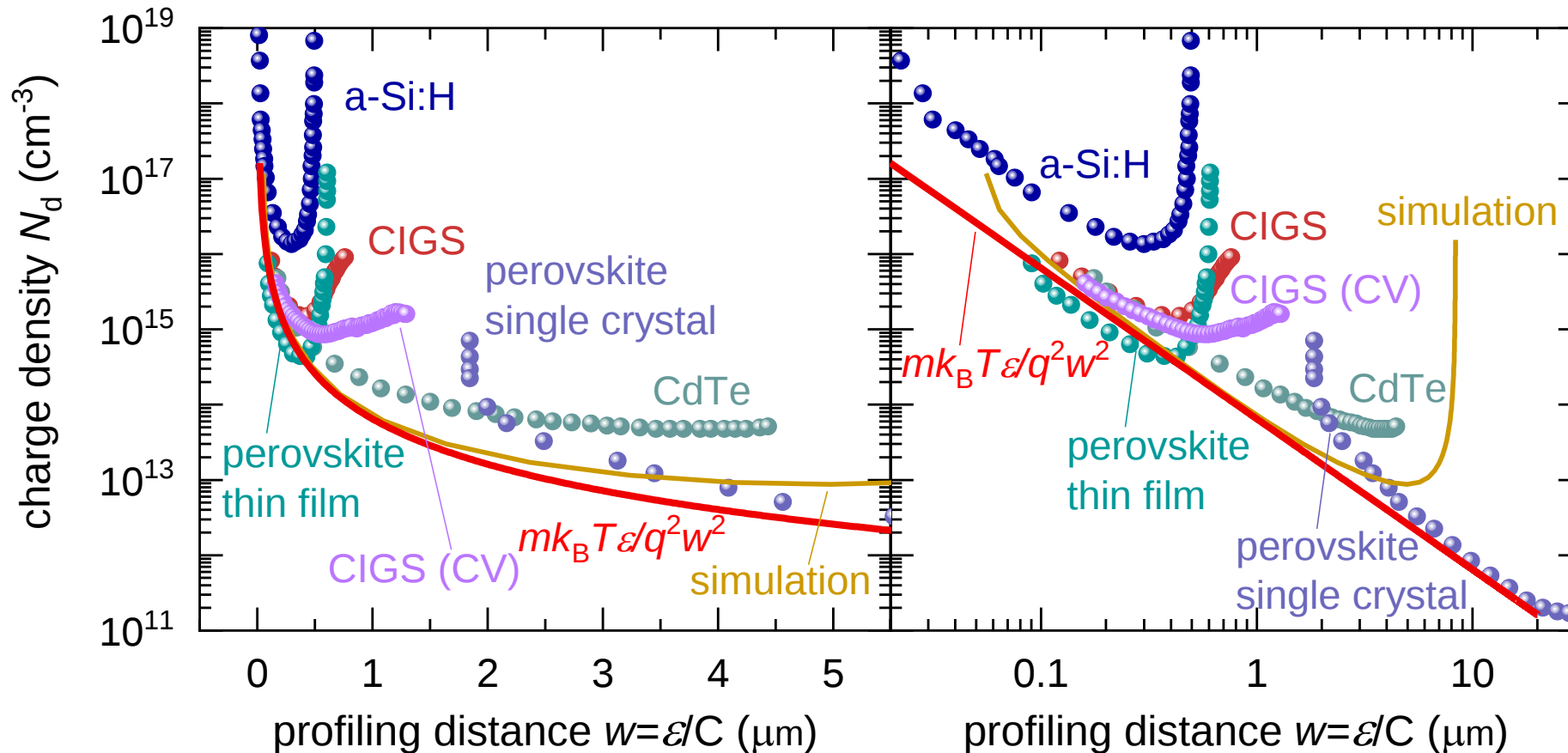
$$C(V) = C_g + C_0 \exp \frac{qV}{mk_B T} \longrightarrow$$

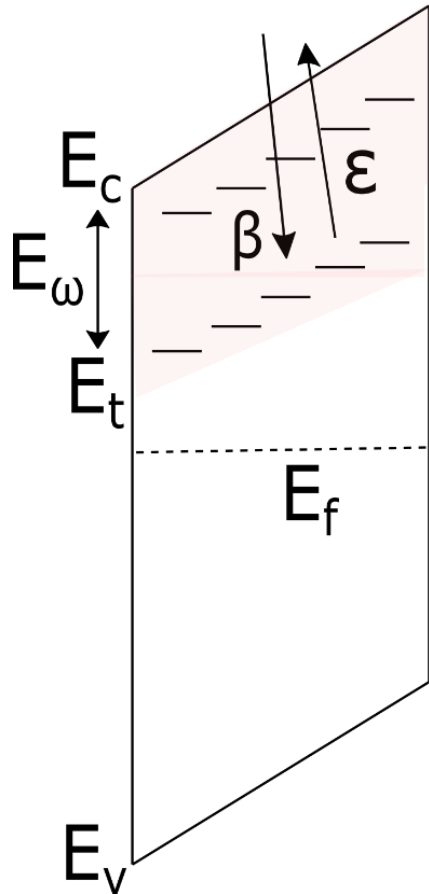
$$N_d(w) = N_{d,\min} + \frac{mk_B T \epsilon_r \epsilon_0}{q^2 w^2}$$



doping profiles of other photovoltaic technologies

Prof. Thomas Unold, Helmholtz Zentrum, Berlin





$$\omega_{td} = \beta \bar{n} + \varepsilon = \beta \bar{n} [1 + \exp(\frac{E_t - E_f}{k_B T})]$$

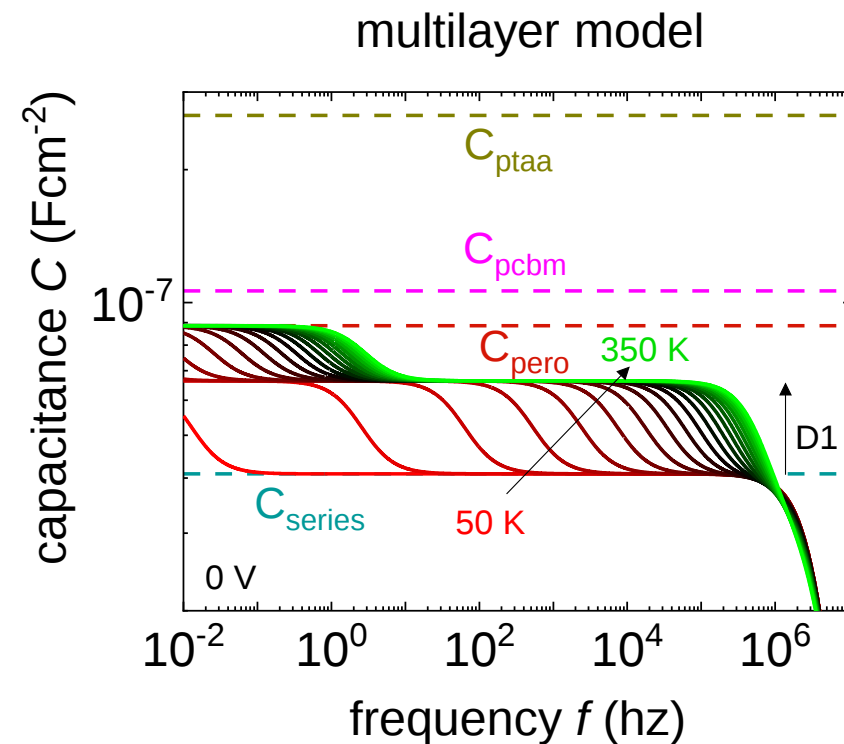
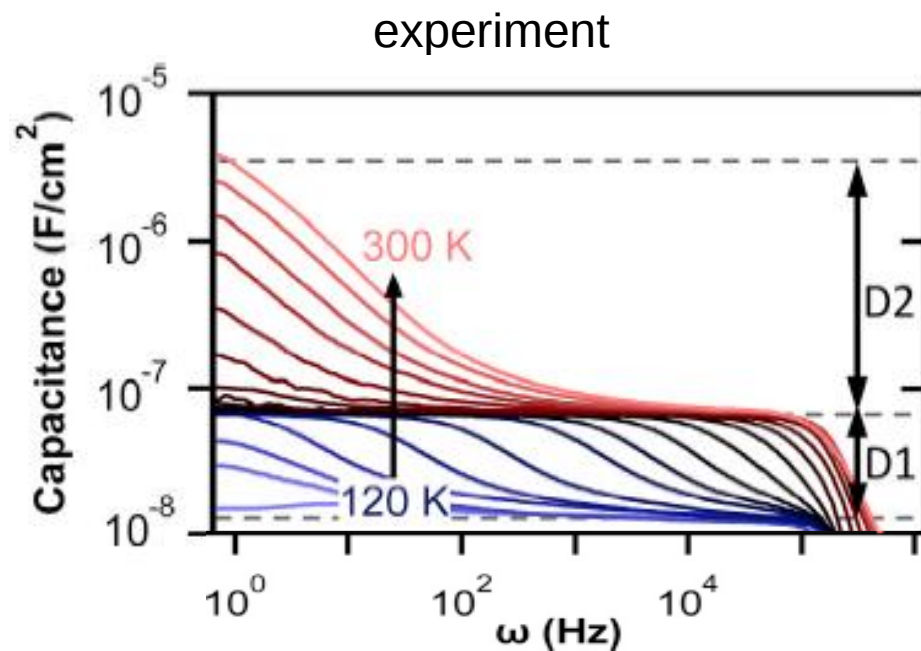
$$\text{For } \frac{E_t - E_f}{k_B T} \gg 1, \quad \omega_{td} = \beta N_c \exp(\frac{-E_\omega}{k_B T})$$

$$C_{\text{trap}}(\omega) = \frac{qd}{\tilde{V}} \frac{\omega_{td}}{\omega^2 + \omega_{td,0}^2} \beta N_t (1 - \bar{f}) \tilde{n}$$

$$\frac{d^2 C_{\text{trap}}}{d\omega^2} = 0 \rightarrow \omega_{td,0} \rightarrow \ln \left(\frac{\omega_{td,0}}{\beta(\propto T^2) N_c} \right) = \frac{-E_\omega}{k_B T}$$

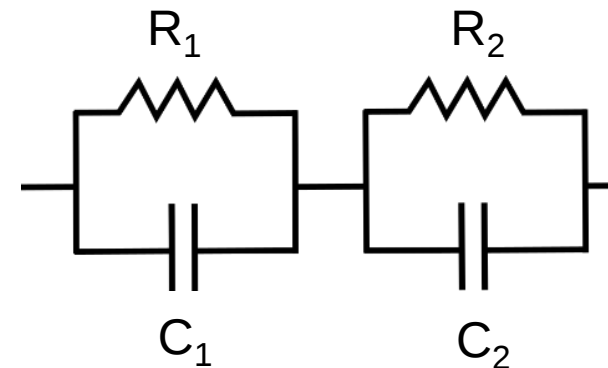
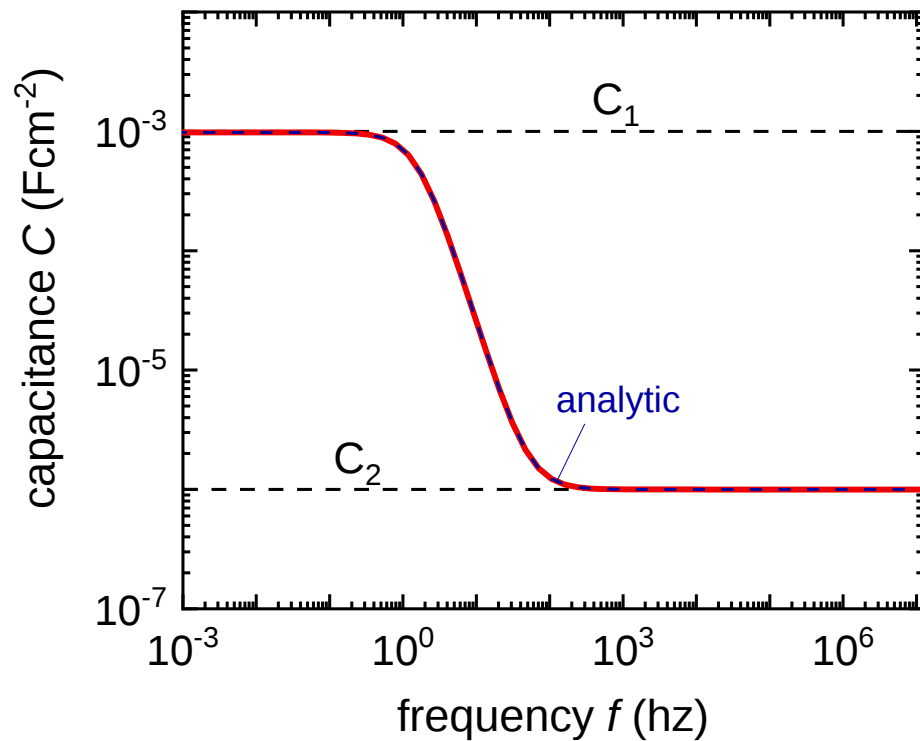
$$\ln \left(\frac{\omega_{\text{inflection}}}{T^2} \right) = \ln k - \frac{E_\omega}{k_B T}$$

slope of inflection frequency/ T^2
versus $1/k_B T$ yields the
activation energy



‘D1’ step ascribed to trapping-detrapping of free carriers, ‘D2’ step ascribed to ionic process

$$R_{\text{ETL}}, R_{\text{HTL}} \propto \frac{1}{k_{\text{B}}T} \exp\left(\frac{q(V_{\text{bi,TL}} - V)}{mk_{\text{B}}T}\right)$$

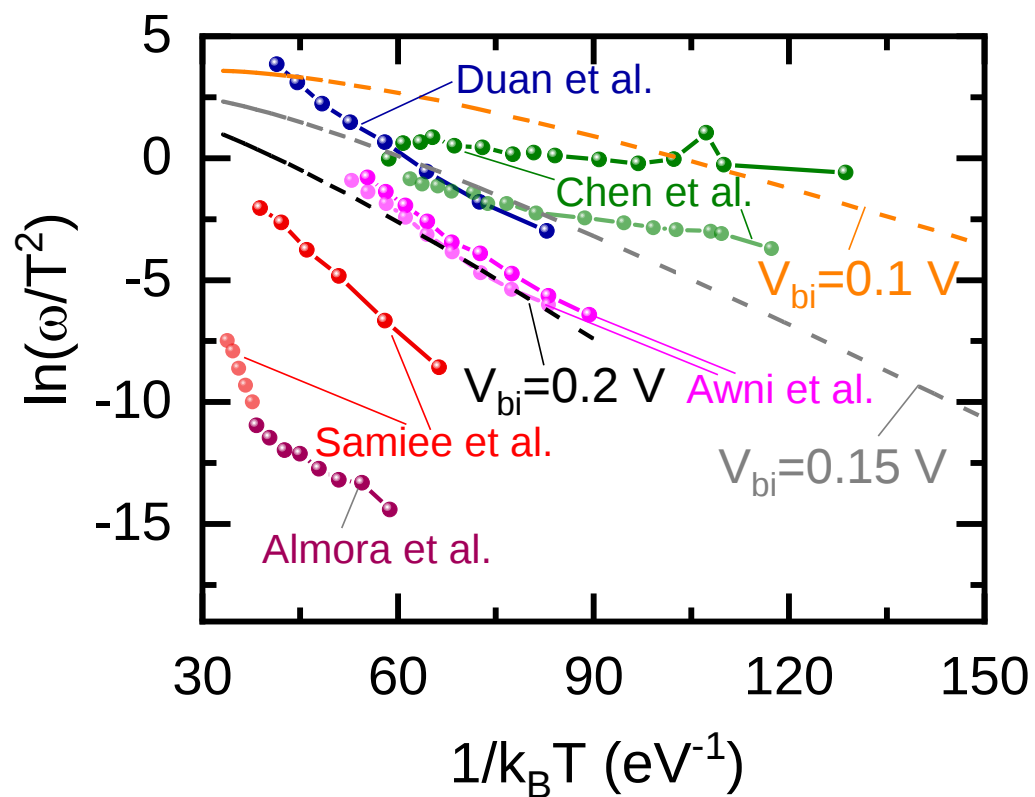


$$C(\omega) = C_2 + \frac{\left(\frac{R_1}{R_{\text{eff}}}\right)^2 C_1}{\left(\frac{R_1 + R_{\text{eff}}}{R_{\text{eff}}}\right)^2 + \left(\frac{\omega}{\omega_1}\right)^2}$$

$$R_{\text{eff}} = R_1(\alpha - 1) + R_2 \longrightarrow \alpha = \sqrt{\frac{R_1^2 C_1}{R_1^2 C_1 + R_2^2 C_2}}$$

$$\omega_{\text{inf}}(\alpha = 1) = \frac{1}{\sqrt{3} R_{||} C_1}$$

$$R_{\text{ETL}}, R_{\text{HTL}} \propto \frac{1}{k_{\text{B}}T} \exp\left(\frac{q(V_{\text{bi,TL}} - V)}{mk_{\text{B}}T}\right) \longrightarrow \omega_{\text{inf}} \propto \frac{1}{k_{\text{B}}T} \exp\left(-\frac{q(V_{\text{bi,TL}} - V)}{mk_{\text{B}}T}\right)$$



$$E_{\text{A}} = \frac{V_{\text{bi,TL}}}{m} - 3k_{\text{B}}T$$

$$C(\omega) = C_0 + \frac{\alpha\tau}{1 + (\omega\tau)^2} \longrightarrow C(t) = C_0 + \alpha \exp\left(\frac{-t}{\tau}\right)$$

general RC transition

$$C(\omega) = C_0 + \frac{\left(\frac{R_1}{R_{\text{eff}}}\right)^2 C_1}{\left(\frac{R_1 + R_{\text{eff}}}{R_{\text{eff}}}\right)^2 + \left(\frac{\omega}{\omega_1}\right)^2}$$

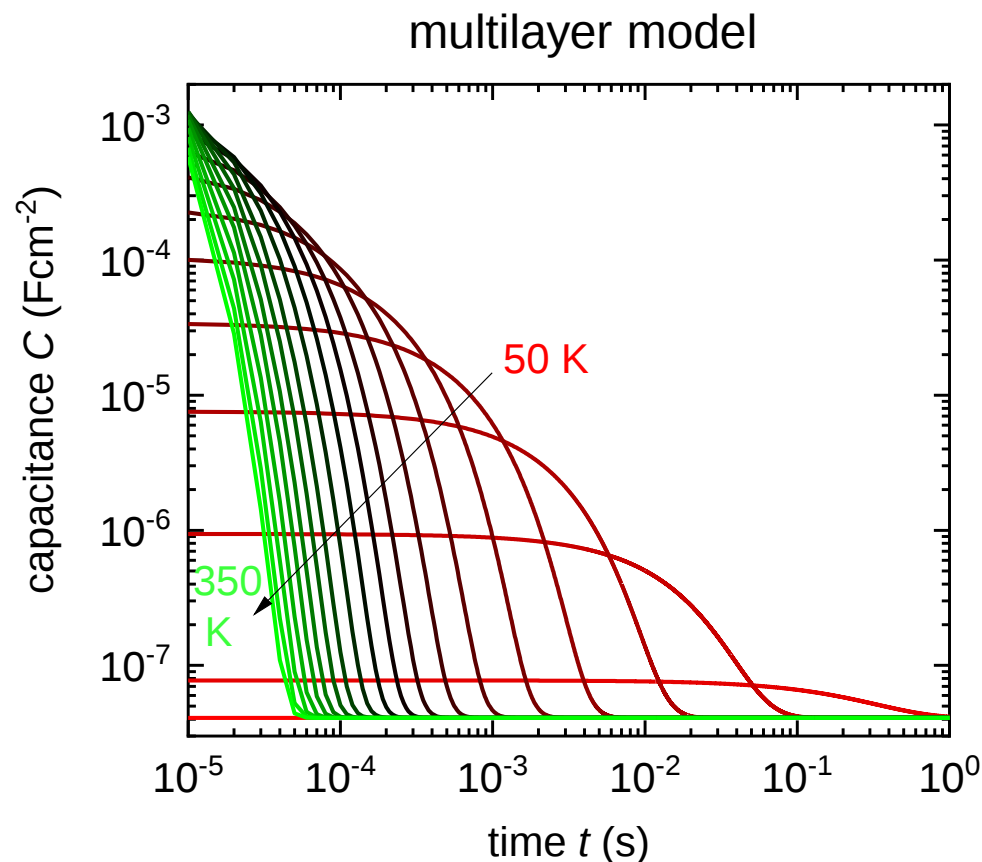
trap capacitance

$$C(\omega) = C_0 + \frac{qd}{\tilde{V}} \frac{\omega_{\text{td}}}{\omega^2 + \omega_{\text{td},0}^2} \beta N_t (1 - \bar{f}) \tilde{n}$$

$$C(\omega) = C_0 + \frac{a}{b + (\omega\tau)^2}$$

$$C(\omega) = C_0 + \frac{\left(\frac{a}{\sqrt{b}\tau}\right) \frac{\tau}{\sqrt{b}}}{1 + \left(\omega \frac{\tau}{\sqrt{b}}\right)^2}$$

deep-level transient spectroscopy (DLTS),
transient ion-drift (TID) $\longrightarrow C(t) = C_0 \mp \alpha \exp\left(\frac{-t}{\tau}\right) \longrightarrow \frac{1}{\tau} \propto \exp\left(\frac{-E_A}{k_B T}\right)$



difficult to differentiate between ionic
diffusion, trapping-detrapping and a
general RC transition

Capacitance measurements on devices will yield a minimum response from the selective contacts that depends on the resistance of the layers.

Capacitance models of PSCs should include the capacitance and resistance of the selective contacts.

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Thank you for your attention